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PATENT APPLICATION
ATTORNEY DOCKET NO. LMRX-P032/P1205

**IN THE
UNITED STATES PATENT & TRADEMARK OFFICE**

Applicant: KIM et al.

Application No. 10/804,430

Examiner: UNKNOWN

Filed: 03/19/2004

Group No. 1763

Title: METHODS FOR THE
OPTIMIZATION OF SUBSTRATE
ETCHING IN A PLASMA PROCESSING
SYSTEM

Confirmation No. 7228

CERTIFICATION OF MAILING OR TRANSMISSION
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to Mail Stop PG Pub, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted to the U.S. Patent & Trademark Office on March 15, 2005. 1 pages transmitted.

By Sandra Halliwell
Sandra Halliwell

**RESCISSON OF PREVIOUS NONPUBLICATION REQUEST
AND, IF APPLICABLE, NOTICE OF FOREIGN FILING**

Dear Sir:

A request that the above-identified application not be published under 35 U.S.C. 122(b) was included with the above-identified application on filing. Applicant hereby rescinds the previous nonpublication request.

If a notice of foreign or international filing is or will be required by 35 U.S.C. 122(b)(2)(B)(iii) and 37 CFR 1.213(c), I hereby provide such notice. This notice is being provided no later than forty-five (45) days after the date of such foreign or international filing.

Respectfully submitted,
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